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Serial No.: 10/676,963

Conf. No.: 8123

Filing Date: 10/01/2003

Art Unit: 2826

Applicant: Gaska et al.

Examiner: Forde, Remmon R.

Title: SEMICONDUCTOR STRUCTURE HAVING A TEXTURED NITRIDE-BASED LAYER Docket No.: SETI-0004

COMMISSIONER FOR PATENTS

DESTINATION PHONE NUMBER: 703-872-9306

Transmitted herewith is: After final Amendment in 9 pages
in the above identified application.

- ☒ No additional fee is required.
- ☒ The Commissioner is hereby authorized to charge and credit Deposit Account No. 500999 as described below.
- ☒ Credit any overpayment.
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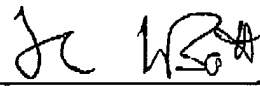
John W. LaBatt, Reg. No. 48,301

DATE: January 12, 2005

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office on the date shown below.

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TEXTURED NITRIDE-BASED LAYER**Docket No.:** SET1-0004

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AFTER FINAL AMENDMENT**Sir:**

This paper is being filed in response to the Final Office Action dated November 17, 2004.

Please amend the above-identified application as follows:

Listing of the Claims begins on page 2 of this paper.

Remarks begin on page 6 of this paper.